

Handwritten initials: #15FW

PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q51885

Akitaka KIMURA

Allowed: July 7, 2004

Appln. No.: 09/161,981

Group Art Unit: 2812

Confirmation No.: 8269

Examiner: Savitri Mulpuri

Filed: September 29, 1998

For: SEMICONDUCTOR LAYER FORMED BY SELECTIVE DEPOSITION AND METHOD
FOR DEPOSITING SEMICONDUCTOR LAYER

SUBMISSION OF REPLACEMENT DRAWINGS

MAIL STOP ISSUE FEE

ATTN: OFFICIAL DRAFTSPERSON

Commissioner for Patents

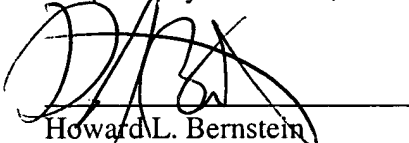
P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

As requested by the examiner, submitted herewith please find 4 sheets of replacement drawings in compliance with 37 C.F.R. § 1.84. The requested drawing change removes "prior art" from Figures 6-9. The Examiner is respectfully requested to acknowledge receipt of these drawings.

Respectfully submitted,


Howard L. Bernstein
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WASHINGTON OFFICE

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CUSTOMER NUMBER

Date: February 1, 2005